

10/581522

AP20RecdPCT/PTO 02 JUN 2006

DOCKET NO.: 292147US26PCT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Toshiaki FUJISATO

SERIAL NO.: NEW U.S. PCT APPLICATION

FILED: HEREWITH

INTERNATIONAL APPLICATION NO.: PCT/JP04/17932

INTERNATIONAL FILING DATE: December 2, 2004

FOR: PLASMA PROCESSING APPARATUS AND MULTI-CHAMBER SYSTEM

REQUEST FOR PRIORITY UNDER 35 U.S.C. 119
AND THE INTERNATIONAL CONVENTION

Commissioner for Patents
Alexandria, Virginia 22313

Sir:

In the matter of the above-identified application for patent, notice is hereby given that the applicant claims as priority:

COUNTRY
Japan

APPLICATION NO
2003-403950

DAY/MONTH/YEAR
03 December 2003

Certified copies of the corresponding Convention application(s) were submitted to the International Bureau in PCT Application No. PCT/JP04/17932.

Respectfully submitted,
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